

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Confirmation No.: 4391

Toshinori OTA, et al.

Date: January 25, 2011

Serial No.: 10/555,855

Group Art Unit: 1795

Filed: November 7, 2005

Examiner: Golam MOWLA

For: THERMOELECTRIC SEMICONDUCTOR MATERIAL, THERMOELECTRIC
SEMICONDUCTOR ELEMENT THEREFROM, THERMOELECTRIC
MODULE INCLUDING THERMOELECTRIC SEMICONDUCTOR ELEMENT
AND PROCESS FOR PRODUCING THESE

VIA EFS-WEB

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Sir:

Applicant notes that there were typographical errors in the Information Disclosure Statement filed on August 29, 2006 in the present patent application. Reference JP2001-053344 should have been listed as a publication of February 2001. Reference JP2001-160633 should have been listed as a publication of June 2001. Reference "JP2001-34587" should have been listed as "JP2001-345487." The Information Disclosure Statement filed July 22, 2010 corrected these mistakes, however, the Office Action mailed September 2, 2010 requested that a new Information Disclosure Statement listing these three references be filed. No deceptive intent was entered in the filing of these Information Disclosure Statements.

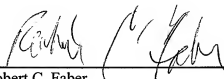
A copy of Form 1449 listing the three above-identified references is filed herewith.

No fee is deemed necessary in connection with the filing of the subject Information Disclosure Statement. However, in the event a fee is required, or if any fee due during the pendency

of this application is not paid, the Patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

THIS CORRESPONDENCE IS BEING
SUBMITTED ELECTRONICALLY
THROUGH THE UNITED STATES
PATENT AND TRADEMARK OFFICE
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2011

Respectfully submitted,



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